

Appl. No. 10/650,601  
Amdt. dated 12/02/2005  
Reply to Office Action of 10/04/2005

RECEIVED  
CENTRAL FAX CENTER  
Attorney Docket No.: TS01-999  
N1085-90151  
JAN 16 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Shi-Chi Lin

Examiner: José R. Diaz

Serial No.: 10/650,601

Group Art Unit: 2815

Filed: August 28, 2003

Confirmation No.: 8321

**For: METHOD OF MANUFACTURING DIELECTRIC ISOLATED SILICON  
STRUCTURE**

I hereby certify that this document (and any documents referred to therein) are being sent by facsimile to  
(571) 273-8300 addressed to the following:

Examiner José R. Diaz  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Date: December 2, 2005

By: Maria E. Provencio  
Maria E. Provencio

Examiner José R. Diaz  
Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION DATED OCTOBER 4, 2005**

Sir:

Responsive to the final Office Action dated October 4, 2005, please re-examine  
and reconsider the above-identified application according to the amendments and  
remarks provided.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

